

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**  
(213.003-US)

In re Application of: **YE ET AL.**

Serial No: **10/677,563**

Filed: **OCTOBER 2, 2003**

Title: **METHOD AND APPARATUS FOR MONITORING  
INTEGRATED CIRCUIT FABRICATION**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

) Group Art Unit: **2857**

) Examiner: **E. RAYMOND**

) I hereby certify that this  
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on **June 6, 2004**  
Date

**Neil Steinberg**  
(name of person signing certificate)

  
Signature

**AMENDMENT AND REMARKS OF JUNE 6, 2004**

Dear Sir:

Kindly amend the application as follows: